

**Search Notes****Application/Control No.**

10/686,636

**Examiner**

Judson H. Jones

**Applicant(s)/Patent under Reexamination**

TANAKA, YONETA

**Art Unit**

2834

**SEARCHED**

Class	Subclass	Date	Examiner
310	12	6/2/2005	JHJ
355	53,72	6/2/2005	JHJ
118	728,729	6/2/2005	JHJ
33	568,573	6/2/2005	JHJ

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
USPTO BRS search search terms: wafer and stage same (piezo or piezoelect\$8) USPAT, PGPUB, EPO, JPO and Derwent	6/4/2005	JHJ

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner